Customer No. 22,852
Attorney Docket No.: **02887.0256**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Masaru KITO	)	
	)	Group Art Unit: **Not Yet Assign d**
Serial No.: **Not Yet Assigned**	)	
	)	Examiner: **Not Yet Assigned**
Filed: **October 16, 2003**	)	
	)	
For: **SEMICONDUCTOR MEMORY AND METHOD OF MANUFACTURING THE SAME**	)	

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicant brings to the Examiner's attention the documents listed on attached Form PTO-1449. With exception of the U.S. patent, a copy of the listed document is attached. Applicant respectfully requests that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form. This Information Disclosure Statement is being filed with the above-referenced application.

The following is a concise statement of relevance of the non-English language document:

1. Japanese Patent Publication No. 2001-352046 – disclose that in order to reduce the GIDL current, the sidewall oxidation film of the gate conductor in a DRAM cell is thicker than that of perimeter transistors. Also, an English-language abstract of this document is enclosed.

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This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicant determines that the cited documents do not constitute "prior art" under United States law, applicant reserves the right to present to the office the relevant facts and law regarding the appropriate status of such documents. Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: October 16, 2003

By: _____
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Enclosures
RVB/FPD/sci

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OMB No. 0651-0011

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	**02887.0256**	Serial No.	**Not Yet Assigned**
Applicant	**Masaru KITO**		
Filing Date	**October 16, 2003**	Group:	**Not Yet Assigned**

U.S. PATENT DOCUMENTS

Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
		6,235,574	05/22/01	TOBBEN et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
		2001-352046	12/21/01	JAPAN			ABSTRACT

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO 1449 — Patent and Trademark Office - U.S. Department of Commerce